Applicant or Pate					
Serial or Patent					
Filed or Issued: For:	September 15, 2000 METAL-ASSISTED CHEMICAL ETCH POROUS SILICON FORMATION METHOD				
roi:	METAL-ASSISTED CHEMICAL ETCHTOROUS SILICON FORMATION METALOGICAL				
VERIF	IED STATEMENT (DECLARATION) CLAIMING SMALL ENTITY STATUS (37 CFR 1.9(f) AND 1.27(d) - NONPROFIT ORGANIZATION)				
•	hat I am an official empowered to act on behalf of the nonprofit organization identified below:				
NAMĖ (OF ORGANIZATION: THE BOARD OF TRUSTEES OF THE UNIVERSITY OF ILLINOIS ADEMARK				
	SS OF ORGANIZATION: 352 Henry Administration Building, 506 S. Wright St., Urbana, IL 61801				
	OF ORGANIZATION:				
	UNIVERSITY OR OTHER INSTITUTION OF HIGHER EDUCATION TAX EXEMPT UNDER INTERNAL REVENUE SERVICE CODE (26 USC 501(a) and 501(c)(3)				
	NONPROFIT SCIENTIFIC OR EDUCATION UNDER STATUTE OF STATE OF THE UNITED STATES OF				
	AMERICA				
•	(NAME OF STATE)				
	(CITATION OF STATUTE				
	WOULD QUALIFY AS TAX EXEMPT UNDER INTERNAL REVENUE SERVICE CODE (26 use 501 (a) and 501				
	(c)(3) IF LOCATED IN UNITED STATES OF AMERICA				
	WOULD QUALIFY AS NON PROFIT SCIENTIFIC OR EDUCATION UNDER STATUTE OF STATE OF THE				
	UNITED STATES OF AMERICA IF LOCATED IN THE UNITED STATES OF AMERICA (NAME OF STATE)				
	(NAME OF STATE) (CITATION OF STATUTE)				
	(OHATION OF STATUTE)				
I hereby declare th	at the nonprofit organization identified above qualifies as a nonprofit organization as defined in 37 CFR 1.9(e) for purposes				
	of paying reduced fees to the United States Patent and Trademark Office with regard to the invention entitled				
	METAL-ASSISTED CHEMICAL ETCH POROUS SILICON FORMATION METHOD by inventor(s)				
	Xiuling Li, Paul W. Bohn and Jonathan V. Sweedler described in:				
() (X)	the specification filed herewith.				
()	application serial no, filed <u>September 15, 2000</u> patent no, issued				
identified invention					
	the above-identified nonprofit organization are not exclusive, each individual, concern, or organization having rights to the				
	below* and no rights to the invention are held by any person, other than the inventor, who would not qualify as an ator under 37 CFR 1.9(c) if that person made the invention, or by any concern which would not qualify as a small business				
	CFR 1.9(d), or a nonprofit organization under 37 CFR 1.9(e). *NOTE: Separate verified statements are required from				
	n, concern, or organization having rights to the invention averring to their status as small entities. (37 CFR 1.27)				
NAME					
ADDRESS	· · · · · · · · · · · · · · · · · · ·				
() IND	IVIDUAL () SMALL BUSINESS CONCERN () NONPROFIT ORGANIZATION				
NAME					
ADDRESS					
	IVIDUAL () SMALL BUSINESS CONCERN () NONPROFIT ORGANIZATION				
	duty to file, in this application or patent, notification of any change in status resulting in loss of entitlement to small entity				
	ng, or at the time of paying, the earliest of the issue fee or any maintenance fee due after the date on which status as a small				
entity is no longer	appropriate. (37 CFR 1.28(b))				
I harabu daalara th	est all statements made barrain of my own knowledge are true, and that all statements made on information and balisform				
	nat all statements made herein of my own knowledge are true, and that all statements made on information and belief are ; and further that these statements were made with the knowledge that willful false statements and the like so made are				
punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements					
	e validity of the application, any patent issuing thereon, or any patent to which this verified statement is directed.				
,,,,,					
NAME OF PERS	ON SIGNING: Craig S. Bazzani				
TITLE IN ORGA	NIZATION: Comptroller and Vice President for Business and Finance				
	ERSON SIGNING: 352 Henry Admin. Bldg., 506 S. Wright St., Urbana, IL 61801				
SIGNATURE					
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As a below named inventor, I hereby declare:

the specification of which (check one)

That my residence, post office address and citizenship are as stated below next to my name.

That I verily believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

METAL-ASSISTED CHEMICAL ETCH POROUS SILICON FORMATION METHOD

() is attached heret	0.				
(X) was filed on	September 15, 2000				
Application Serial No.					
and was amended on _	(10 tr 11)				
	(if applicable))			
That I have revie amendment referred to		ntents of the above-identified	specification, including th	ie claims, as	amended by any
	lge the duty to disclose info al Regulations, §1.56(a).	ormation known to be materia	l to patentability of this ap	plication in	accordance with
inventor's certificate lis	ted below and have also is	under Title 35, United States dentified below any foreign application on which priority is	application for patent or i	n applicatio nventor's co	n(s) for patent or ertificate on this
Prior Foreign Application(s)				Priority	/ Claimed
				()	()
				Yes	No
(Number)	(Country)	(Day/Month/Y	ear Filed)		
				()	()
				Yes	No
(Number)	(Country)	(Day/Month/Y	ear Filed)		
				()	()
				Yes	No
(Number)	(Country)	(Day/Month/Y	ear Filed)		
insofar as the subject maprovided by the first padefined in Title 37, Cod	atter of each of the claims o ragraph of Title 35, Unite	35, United States Code, §120 fthis application is not disclored States Code, §112, I ackn §1.56(a) which occurred be plication:	sed in the prior United Sta owledge the duty to discl	tes applicati ose materia	on in the manner l information as
United States Applicat	tion(s)				
(Application Serial No.)	(Filing Date)	(Status)-(Pate	nted, pendi	ng, abandoned)
(Application Serial No.)	(Filing Date)	(Status)-(Pate	nted, pendi	ng, abandoned)
(Application Serial No.)	(Filing Date)	(Status)-(Pate	nted, pendi	ng, abandoned)

That all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

I hereby appoint the following attorneys and agents, with full power of substitution and revocation, to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith and request that all correspondence and telephone calls in respect to this application be directed to GREER, BURNS & CRAIN, LTD., Suite 8660 - Sears Tower, 233 South Wacker Drive, Chicago, Illinois 60606, Telephone No. (312) 993-0080:

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